



Docket No.: 49657-961

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Kenji ITOGA, et al.

Serial No.: 09/769,490

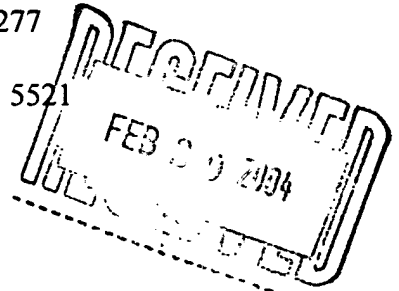
Filed: January 26, 2001

: Customer Number: 20277

: Confirmation Number: 5521

: Group Art Unit: 2882

: Examiner: C. Kao



For: X-RAY EXPOSURE APPARATUS, X-RAY EXPOSURE METHOD, X-RAY MASK,  
X-RAY MIRROR, SYNCHROTRON RADIATION APPARATUS, SYNCHROTRON  
RADIATION METHOD AND SEMICONDUCTOR DEVICE

**PETITION FOR EXTENSION OF TIME**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time for response to the Office Action dated  
September 16, 2003, now due to expire December 16, 2003, be extended for two (2) months and  
set to expire on **February 17, 2004** (February 16, 2004 being a US government holiday). Please  
charge the extension fee of \$420.00 to Deposit Account No. 500417. Please charge any  
additional fees or credit any overpayment to Deposit Account No. 500417.

02/19/2004 MAHMED1 00000042 500417 09769490  
02 FC:1252 420.00 DA

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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**Date: February 17, 2004**